Course Guide M3-44419 Physical characterisation techniques

COURSE DATA

Data Subject				
Code	M3-44419			
Name	Physical characterisation techniques			
Cycle	Master's degree			
ECTS Credits	4.5			
Study (s)				
Degree		Center	Acad. Period year	
2208 - Master's Degree in Molecular Nanoscience and Nanotechnology		Faculty of Chemistry	1 First term	
Subject-matter				
Degree 2208 - Master's Degree in Molecular Nanoscience and Nanotechnology		Subject-matter 3 - Physical characterisation techniques	Character Obligatory	
Coordination				
Name		Department		
OTERO MARTÍN, ROBERTO		Condensed Matter Physics- U. Autónoma de Madrid		

SUMMARY

The aim of this subject is to make the students familiar with physical characterization techniques usually employed in nanoscience (microscopy and spectroscopy), with emphasis on surface sensitive characterization and analysis techniques.

PREVIOUS KNOWLEDGE

Relationship to other subjects of the same degree

There are no specified enrollment restrictions with other subjects of the curriculum.

Other requirements

Previous knowledge of chemistry, physics or materials science as taught in the degrees indicated in the recommended entry profile to the master's degree is required. Previous knowledge of molecular nanoscience and nanotechnology as taught in the Introduction Module is required.

COMPETENCES (RD 1393/2007) // LEARNING OUTCOMES (RD 822/2021)

2208 - Master's Degree in Molecular Nanoscience and Nanotechnology

- Students should apply acquired knowledge to solve problems in unfamiliar contexts within their field of study, including multidisciplinary scenarios.
- Students should be able to integrate knowledge and address the complexity of making informed judgments based on incomplete or limited information, including reflections on the social and ethical responsibilities associated with the application of their knowledge and judgments.
- Students should demonstrate self-directed learning skills for continued academic growth.
- Students should possess and understand foundational knowledge that enables original thinking and research in the field.
- To possess the necessary knowledge and abilities to continue with future studies in the PhD program in Nanoscience and Nanotechnology.
- For students from field of knowledge (e.g. chemistry) to be able to scientifically communicate and interact with colleagues from another field (e.g. physics) in the resolution of problems laid out by the Molecular Nanoscience and Nanotechnology.
- To acquire the basics knowledge in fundamentals, use and applications of microscopic and spectroscopic techniques used in nanotechnology.
- To know the technical and conceptual problems laid out by the physical properties measurement in single molecular systems (charge transport, optical properties, magnetic properties).

LEARNING OUTCOMES (RD 1393/2007) // NO CONTENT (RD 822/2021)

The aim of this subject is to make the students familiar with physical characterization techniques usually employed in nanoscience (microscopy and spectroscopy), with emphasis on surface sensitive characterization and analysis techniques.

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DESCRIPTION OF CONTENTS

1. Physical characterization techniques.

CHAPTER 1: Far-field microscopies.

- 1.1. Introduction
- 1.2. Optical microscopies
- 1.2.1. Overview of geometrical optics
- 1.2.2. Resolution limits and superresolution techniques: Aberrations and diffraction
- 1.3. Electron microscopies
- 1.3.1. Fundamentals
- 1.3.2. Instrumentation: electron sources and electrostatic lenses
- 1.3.3. TEM, SEM y STEM
- 1.3.4. Information that can be obtained from the different signals.

CHAPTER 2: Optical spectroscopies.

- 2.1. Optical properties of nanostructures: quantum confinement, excitons and plasmons.
- 2.2. Absorption and luminescence spectroscopies: energy gaps and the Frank-Condon principle.
- 2.3. Infrared and Raman spectroscopies: vibrations
- 2.4. Pump-probe spectroscopy: Excitation lifetimes.

CHAPTER 3: Photoelectron spectroscopies.

- 3.1. Photoelectric effect, work function, electron mean-free path and final state effects (screening).
- 3.2. Instrumentation: Light sources, monochromators, flood guns, energy analyzers
- 3.3. Instrumentation: Ultra-High Vacuum and sample preparation techniques in UHV
- 3.4. X-ray Photoelectron Spectroscopy (XPS): Chemical identification and Chemical shifts.

3.5. Ultraviolet Photoelectron Spectroscopy (UPS): Valence band, angle resolved UPS, band dispersion.

3.6. Synchrotron-based techniques: Near-Edge X-ray Absorption Fine Structure (NEXAFS) and magnetic dichroism.

CHAPTER 4: Scanning probe microscopies.

- 4.1. Scanning Tunneling Microscopy
- 4.1.1. Theoretical foundations and instrumentation.
- 4.1.2. Topographical and spectroscopic information with the STM
- 4.1.3. Inelastic spectroscopy and elementary excitations
- 4.1.4. STM manipulation
- 4.2. Atomic Force Microscopy
- 4.2.1. Theoretical foundations and instrumentation
- 4.2.2. Topography, friction and Force vs. Distance curves
- 4.2.3. Mechanical properties of nanostructures

4.3. Other Scanning Probe Microscopies: Magnetic Force Microscopy (MFM) and Scanning Near-field Optical Microscopy (SNOM)

WORKLOAD

ACTIVITY	Hours	% To be attended
Theory classes	22,00	100
Seminars	7,00	100
Tutorials	6,00	100
Other activities	2,00	100
Preparation of evaluation activities	57,50	0
Preparing lectures	18,00	0
ΤΟΤΑΙ	112,50	

TEACHING METHODOLOGY

The classes of this subject will be taught, together with the rest of the basic module, intensively during 3 weeks in January and each year at a different university.

During the **theory classes**, the teaching staff will give an overview of the subject under study, emphasising new or particularly complex aspects. The necessary bibliographical sources will be indicated for students to study the subject in depth.

The **practical classes** of this subject will be devoted to the organisation of seminars in which problems related to the theoretical content will be posed and solved. Likewise, practical cases and other topics related to the subject will be discussed with the students.

During these hours of practical activities, as far as possible, visits to laboratories and facilities related to the contents of the theoretical classes will be organised. This includes visits to laboratories for advanced physical characterisation of nanomaterials by microscopic (including AFM, STM, TEM and SEM), spectroscopic (including XPS, IR and Raman) and diffraction (including X-ray on single crystal and powder) techniques.

After the intensive face-to-face classes, the lecturers will ask students a series of **questions** about the contents of the course that the student will have to solve.

Professors will hold **tutorials** with the students to resolve any doubts and questions they may have. These tutorials will take place in person or remotely (email, videoconference, telephone, etc.) depending on whether the student and teacher are from the same or a different university.

Through all these activities, students will acquire the competences described in the corresponding section. The basic competences will be worked on above all during the seminars.

EVALUATION

The acquisition of the competences of the subject will be assessed by means of a written exam based on the questions posed to the students. The mark for this exam will represent 90% of the final mark for the subject.

Student participation during the training activities will represent 10% of the final grade.

In order to pass the course, it will be necessary to have attended 80% of the face-to-face training activities.

REFERENCES

Basic

- Practical Methods in Electron Microscopy. Ed. Glauer, A.M. Nort Holland Publishing Company. 1990-1997

Desarrollo de técnicas de espectroscopía láser y su aplicación al análisis químico, Montero Catalina, Carlos, Universidad Complutense de Madrid, Servicio de Publicaciones, 2001. Introduction to Scanning Tunneling Microscopy. Chen, C.J. Oxford Scholarship Online. 2007.